



Attorney Docket No. 0756-7176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji DAIRIKI

Serial No. 10/625,737

Filed: July 24, 2003

For: SEMICONDUCTOR DEVICE

MANUFACTURING METHOD, HEAT

TREATMENT APPRATUS, AND

HEAT TREATMENT METHOD

) Group Art Unit: 2822

) Examiner: M. Guerrero

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is  
) being deposited with the United States Postal  
) Service with sufficient postage as First Class  
) Mail in an envelope addressed to:  
) Commissioner for Patents, P.O. Box 1450,  
) Alexandria, VA 22313-1450, on May 16, 2005.

) Adrian M. Stamps

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated February 16, 2005, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.

05/18/2005 SSESHE1 00000027 10625737 50.00 0P  
01 FC:1202